

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:

T. ARAI, et al.

Application No.:

10/085,063

Filed:

March 1, 2002

For:

FABRICATION METHOD OF SEMICONDUCTOR

INTEGRATED CIRCUIT DEVICE

Group:

1765

Examiner:

B. X. Tran

Conf. No.:

9140

AMENDMENT

Mail Stop: Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

June 27, 2005

Sir:

In response to the Office Action mailed March 25, 2005, please amend the above-identified application as listed in the following, and as set forth on the following pages:

AMENDMENTS TO THE CLAIMS; and

REMARKS are included following the Amendments.